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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OHASHI, Hitoshi et al.**

Group Art Unit: **1792**

Serial No.: **10/047,992**

Examiner: **Brian K. Talbot**

Filed: **January 17, 2002**

P.T.O. Confirmation No.: **5363**

Docket: **020052**

Date: **October 14, 2009**

For: **METHOD AND APPARATUS FOR FORMING
ELECTRIC CIRCUIT FIXING THE SEMICONDUCTOR
DEVICE USING SUBSTRATE JIG**

AMENDMENT and PETITION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Office Action dated June 29, 2009, extended to October 19, 2009. This paper is a Petition for an appropriate extension of time. Please charge the fees needed for such an extension of time, and any other fees which may be needed to enter this paper, to **Deposit Account No. 01-2340**.

The following listing of claims will replace all prior versions, and listings, of claims.